

Notice of References Cited	Application/Control No. 10/800,827	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Kezhen Shen	Art Unit 2627	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2005/0050100 A1	03-2005	Chin, Yuan-Chang	707/104.1
*	C	US-2004/0252967 A1	12-2004	Sheu et al.	386/046
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NON-PATENT DOCUMENTS

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